

INTERNATIONAL  
GEMOLOGICAL  
INSTITUTE

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LABORATORY GROWN DIAMOND REPORT

October 16, 2025

IGI Report Number

Description

Shape and Cutting Style

Measurements

GRADING RESULTS

Carat Weight

Color Grade

Clarity Grade

ADDITIONAL GRADING INFORMATION

Polish

Symmetry

Fluorescence

Inscription(s)

Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process. Type IIa

Report verification at [igi.org](http://igi.org)

PROPORTIONS

Medium


61%

14.5%

47%

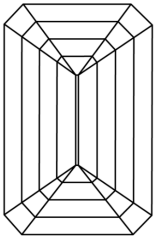
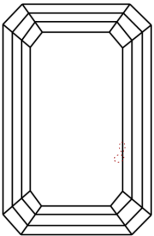
64.3%

Long



Sample Image Used

CLARITY CHARACTERISTICS



KEY TO SYMBOLS

Red symbols indicate internal characteristics.  
Green symbols indicate external characteristics.

COLOR

D E F G H I J Faint Very Light Light

CLARITY

FL IF VVS<sup>1-2</sup> VS<sup>1-2</sup> SI<sup>1-2</sup> I<sup>1-3</sup>

Flawless Internally Flawless Very Very Slightly Included Very Slightly Included Slightly Included Included

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IGI Report No

EMERALD CUT

9.79 X 6.86 X 4.41 MM

3.00 CARATS

D

VS 1

64.3%

61%

14.5%

47%

Medium

Long

EXCELLENT

EXCELLENT

NONE

IGI

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